

Docket No.: 50432-645

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277

Douglas J. BONSER, et al. : Confirmation Number:

Serial No.: : Group Art Unit:

Filed: March 04, 2004 : Examiner: Unknown

For: METHOD OF REDUCING STI DIVOT FORMATION DURING SEMICONDUCTOR
DEVICE FABRICATION

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

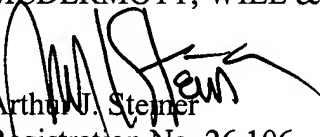
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Serial No.:

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Respectfully submitted,

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Date: March 4, 2004

INFORMATION DISCLOSURE CITATION IN AN APPLICATION						ATTY. DOCKET NO. 50432-645		SERIAL NO.			
(PTO-1449)						APPLICANT Douglas J. BONSER, et al.					
						FILING DATE March 04, 2004		GROUP			
U.S. PATENT DOCUMENTS											
EXAMINER'S INITIALS		CITE NO.	Document Number Number-Kind Code ² (<i>if known</i>)		Publication Date MM-DD-YYYY		Name of Patentee or Applicant of Cited Document		Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
			US	2002/0098661 A1	07/25/2002		Cha et al.				
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FOREIGN PATENT DOCUMENTS											
EXAMINER'S INITIALS		CITE NO.	Foreign Patent Document Country Codes - Number + Kind Codes (<i>if known</i>)		Publication Date MM-DD-YYYY		Name of Patentee or Applicant of Cited Document		Pages, Columns, Lines Where Relevant Figures Appear	Translation	
										Yes	No
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)											
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Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.